

Demonstration of the Hall Effect in Semiconductors

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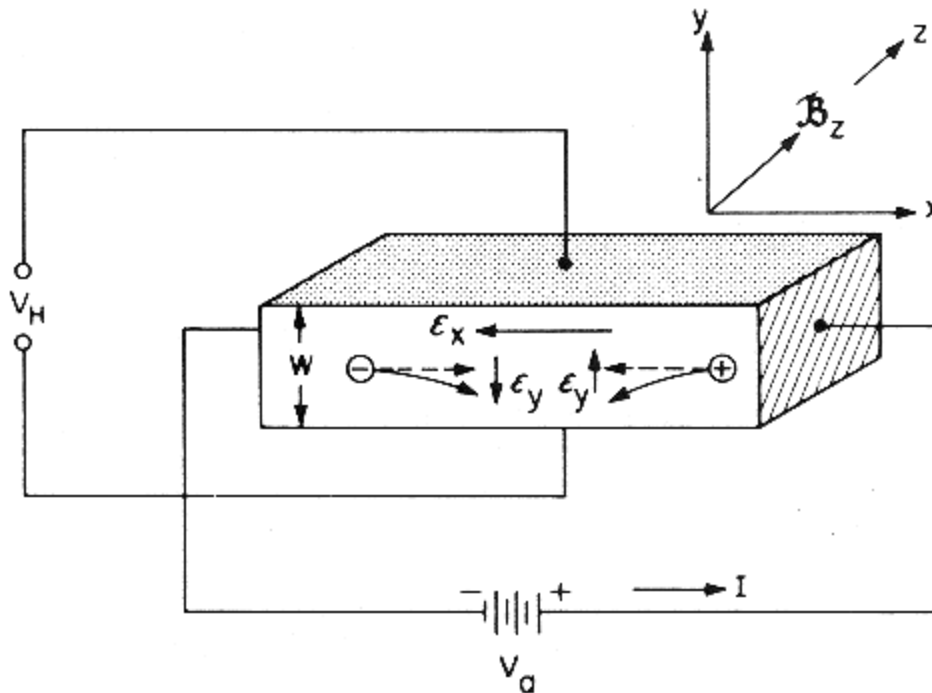
A decorative graphic consisting of several horizontal lines of varying lengths and colors (teal, light blue, white) extending from the right side of the slide towards the center.

The Hall Effect

- Discovered in 1879 by Edwin Hall
- It is the development of a potential difference in a conductor transverse to the current passing through the conductor and the magnetic field perpendicular to the current
- $F=q(E+v \times B)$

Hall Effect in semiconductors

- Holes and electrons



- $$V_H = \frac{R_H B I}{w}$$

- $$R_H = \frac{(p\mu_h^2 - n\mu_e^2)}{e(n\mu_e + p\mu_h)^2}$$

- This can be derived from definition of R_H

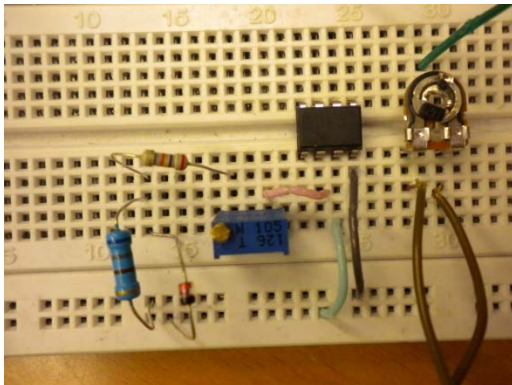
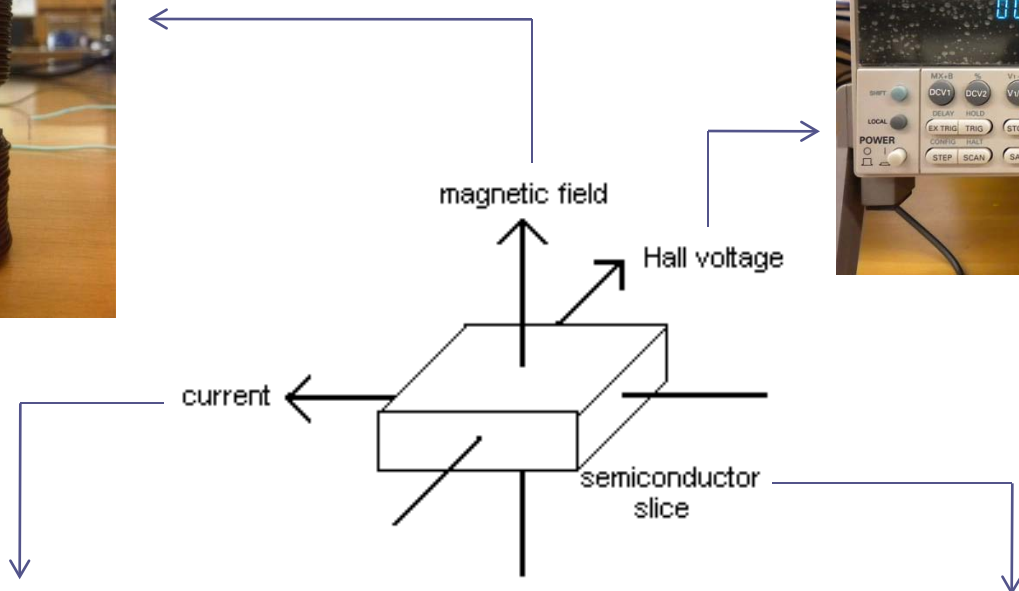
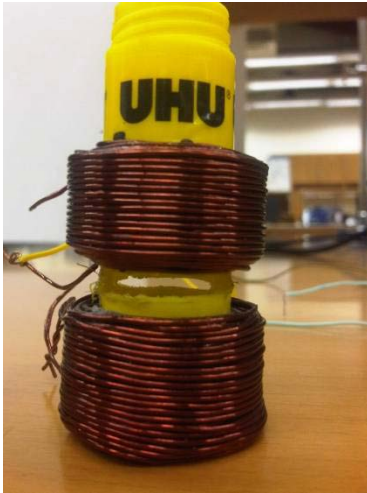
$$R_H = E_y / (j_x B)$$

μ_e = electron mobility

μ_h = hole mobility

n = electron density

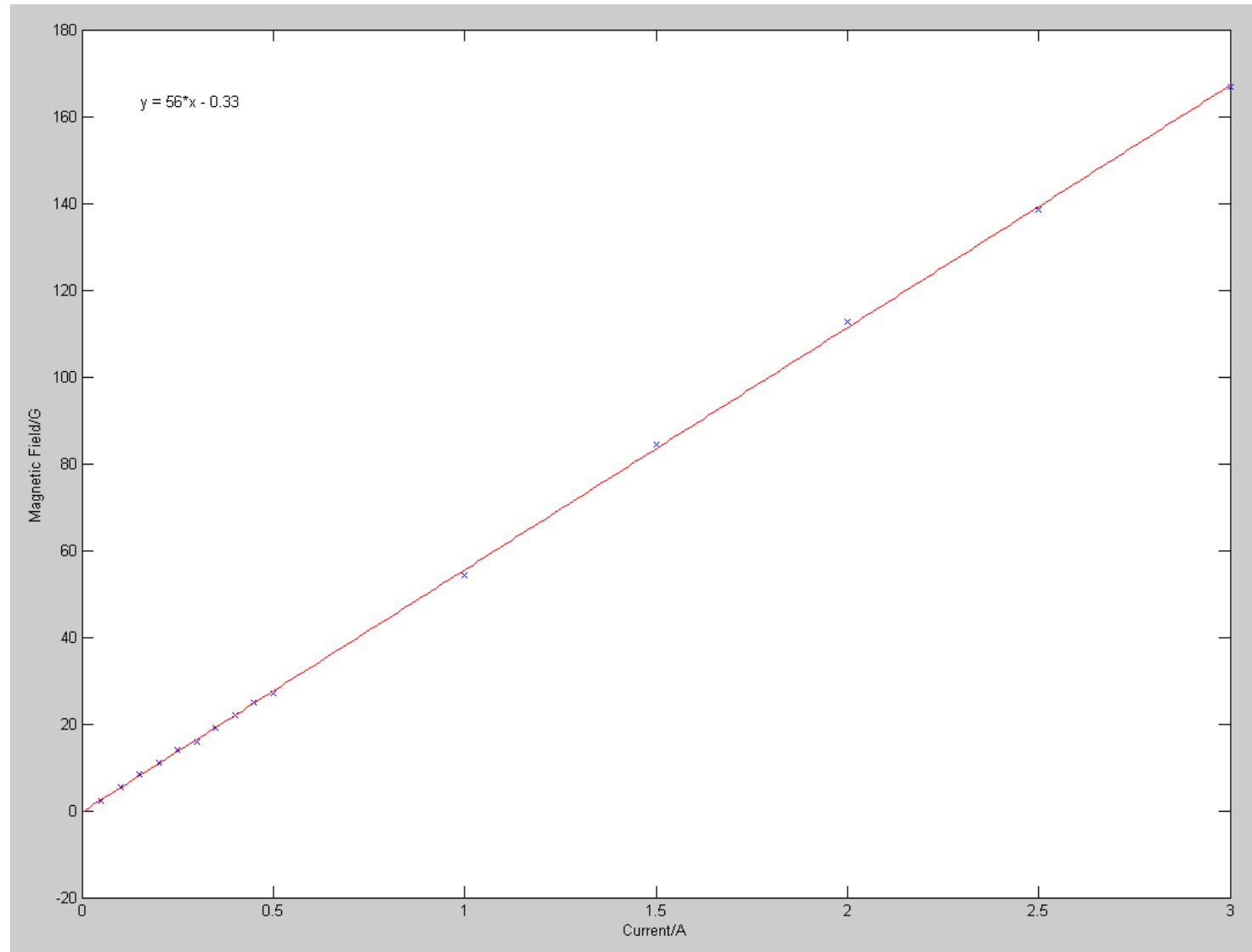
p = hole density



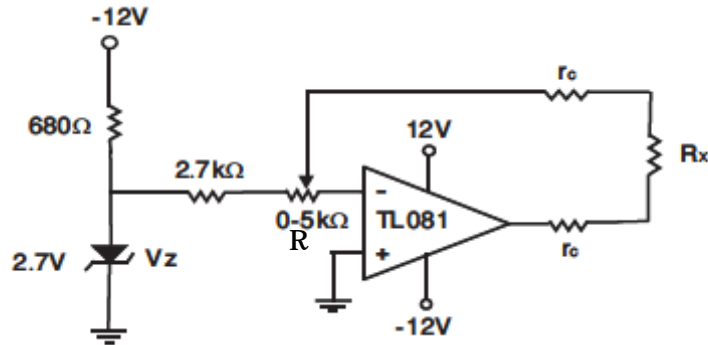
Magnetic Field

- Helm holtz coil
- Current provided using simple DC power supply
- Able to produce fields of upto 170G/0.017T
- Slide on which semiconductor rests is inserted into the coil
- Average deviation of B from maximum value = 5.4%
- Measured using Gaussmeter (axial probe)

Current through coil vs. Magnetic field



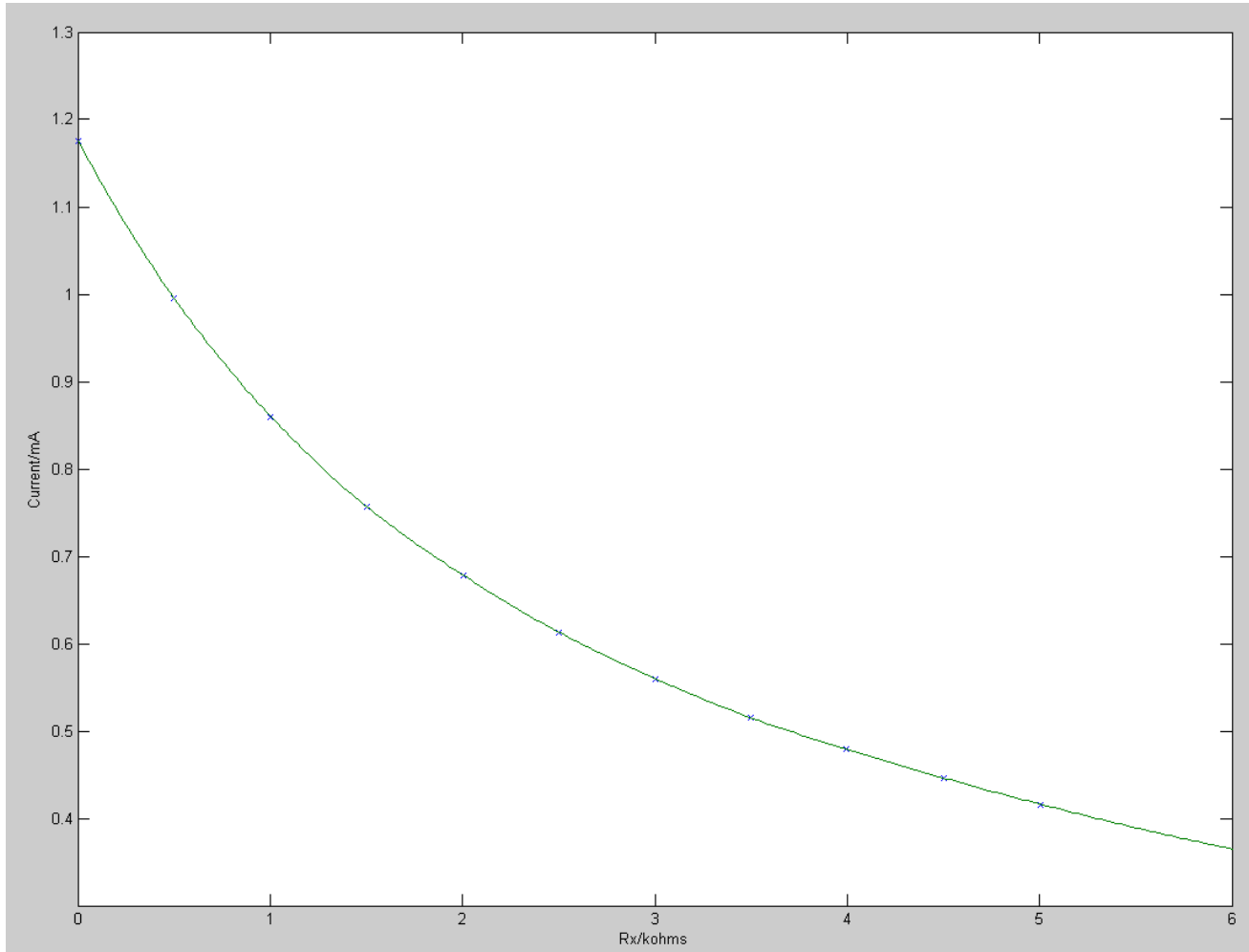
Constant Current Source



TL081 Opamp
 R_x Load
 $I_x = 3.2 / (2.7k + R)$

Stable for up to 0.1μA

R_x vs. I_x



Voltmeter and Ammeter



Keithley nanovoltmeter

A microvoltmeter can replace this



Keithley picoammeter

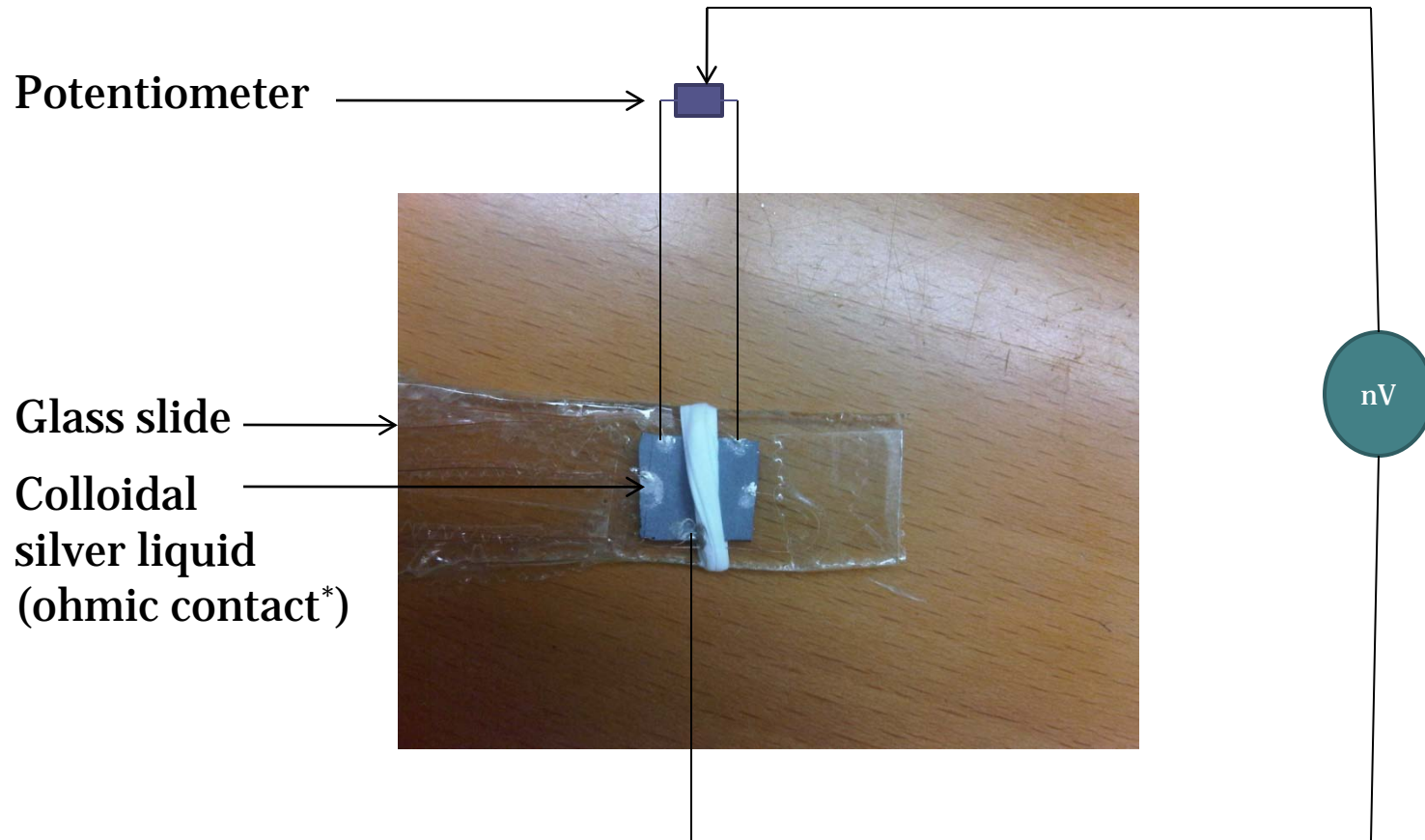
Can be replaced with a microammeter



Keithley DC & AC current source

Used in delta mode; no ammeter needed when this is used

Silicon Samples



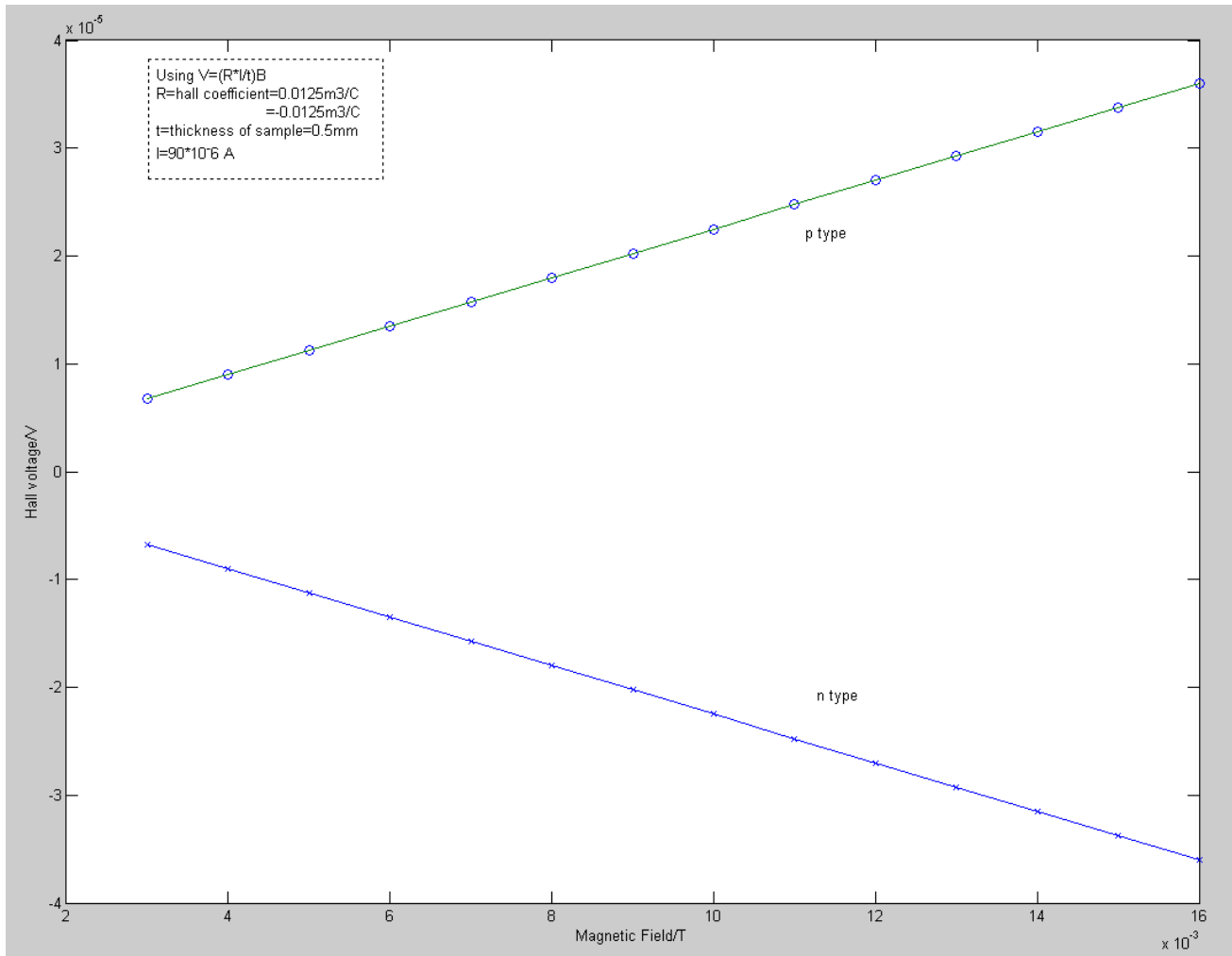
*Region of a semiconductor with linear I-V characteristics

- Glass slide is cut to fit into the slot in the helmholtz coil
- Potentiometer used to correct zero error in zero magnetic field with constant current flowing
- The metal-semiconductor contact is made using colloidal silver liquid. This contact must be ohmic for the readings to be accurate

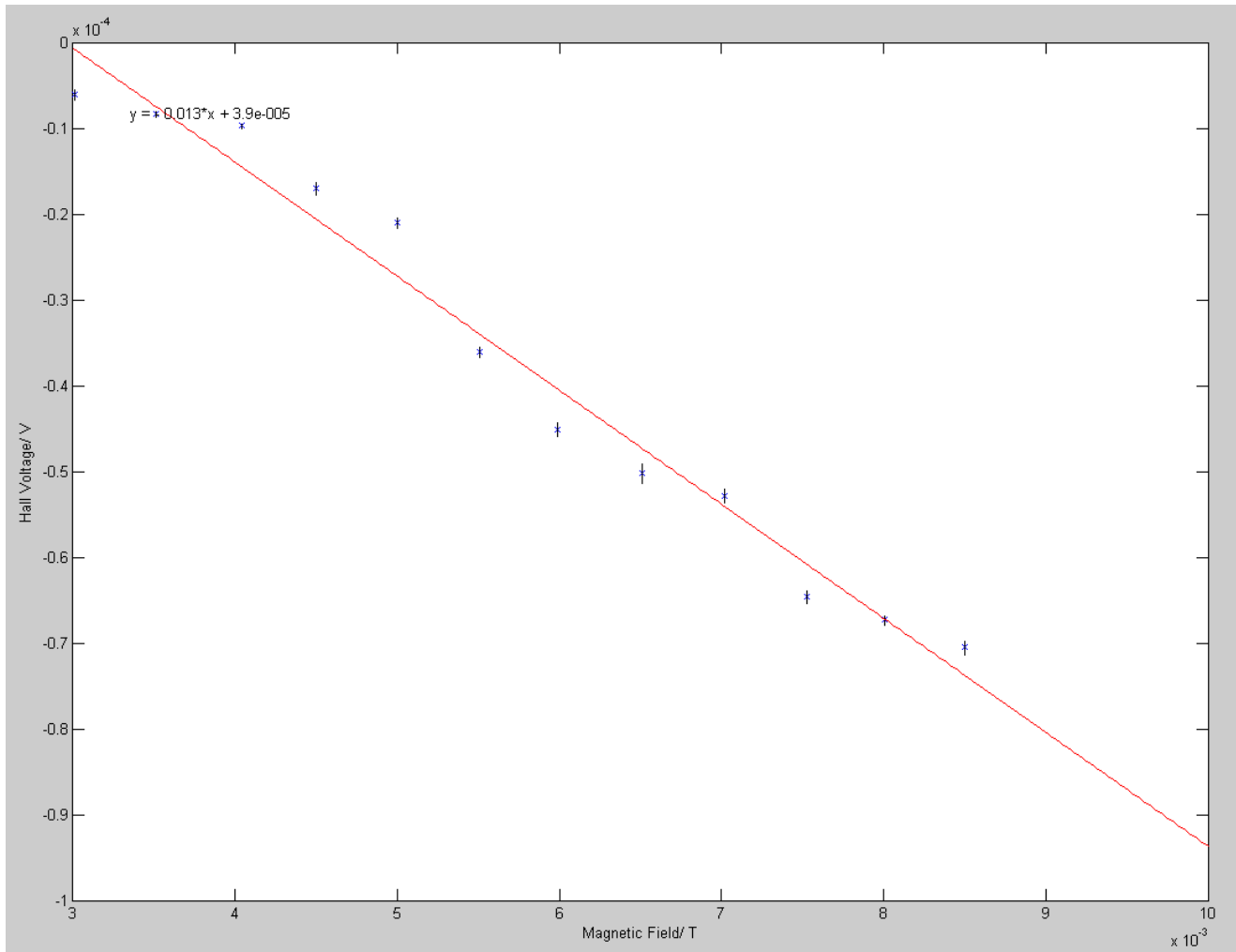
The Experiment & Results

- Experiment was first conducted using n-type sample, with constant current source made with circuit
- Potentiometer not used in this experiment

Simulated Result for B vs. V_H



Measured Results for B vs. V_H (n type)



- **Simulated results** gradient = $-0.0027 \text{ m}^3\text{C}^{-1}$
- **Measured results** gradient = $-0.013 \text{ m}^3\text{C}^{-1}$
- **Discrepancy** could be due to a number of reasons:

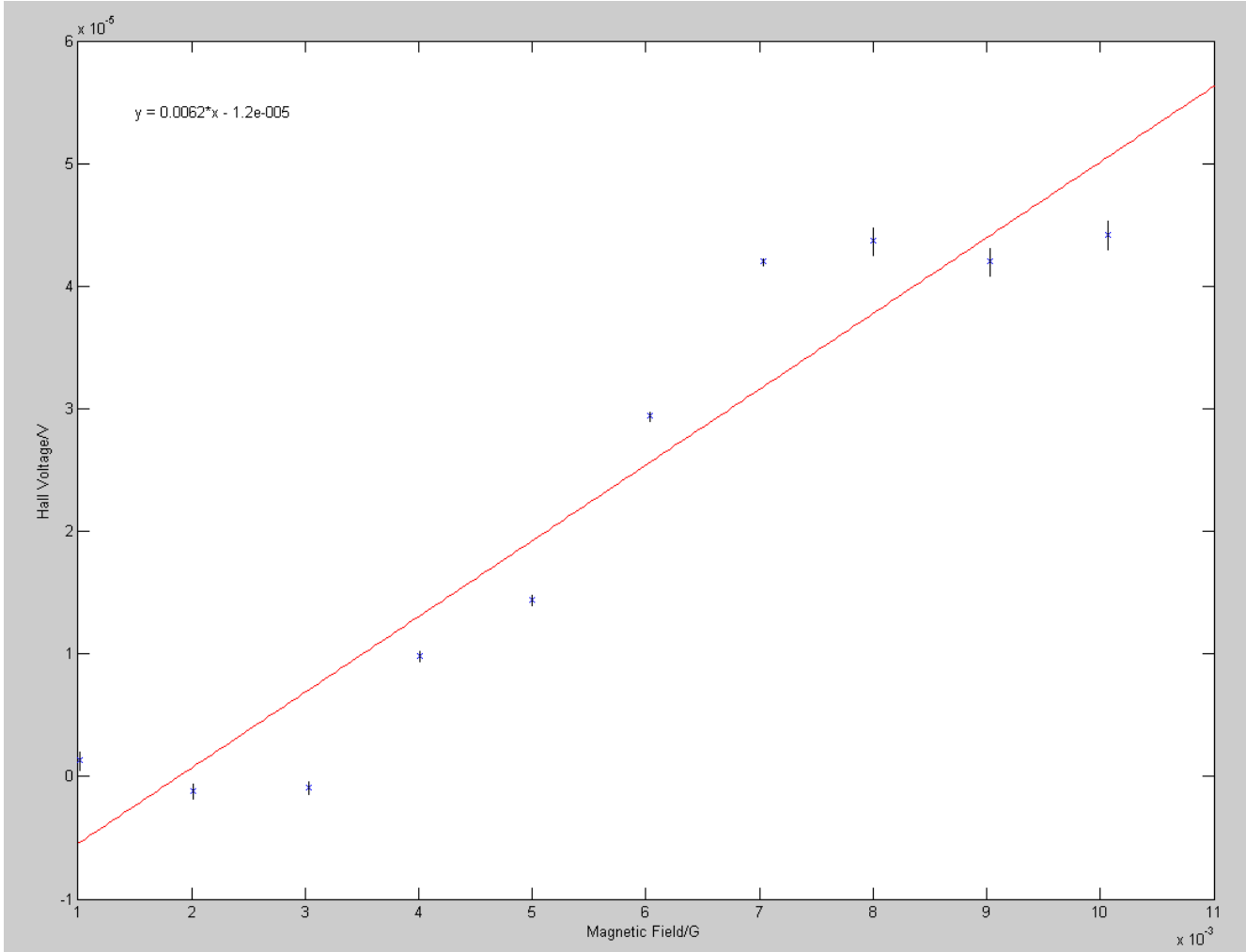
Noise

Approximations used in calculation of simulated results

Exact ratio of doping unknown (10^6 - 10^8)

- Same procedure followed for p-type silicon
- The direction of current, magnetic field and voltmeter connections must be kept the same

Measured Results for B vs. V_H



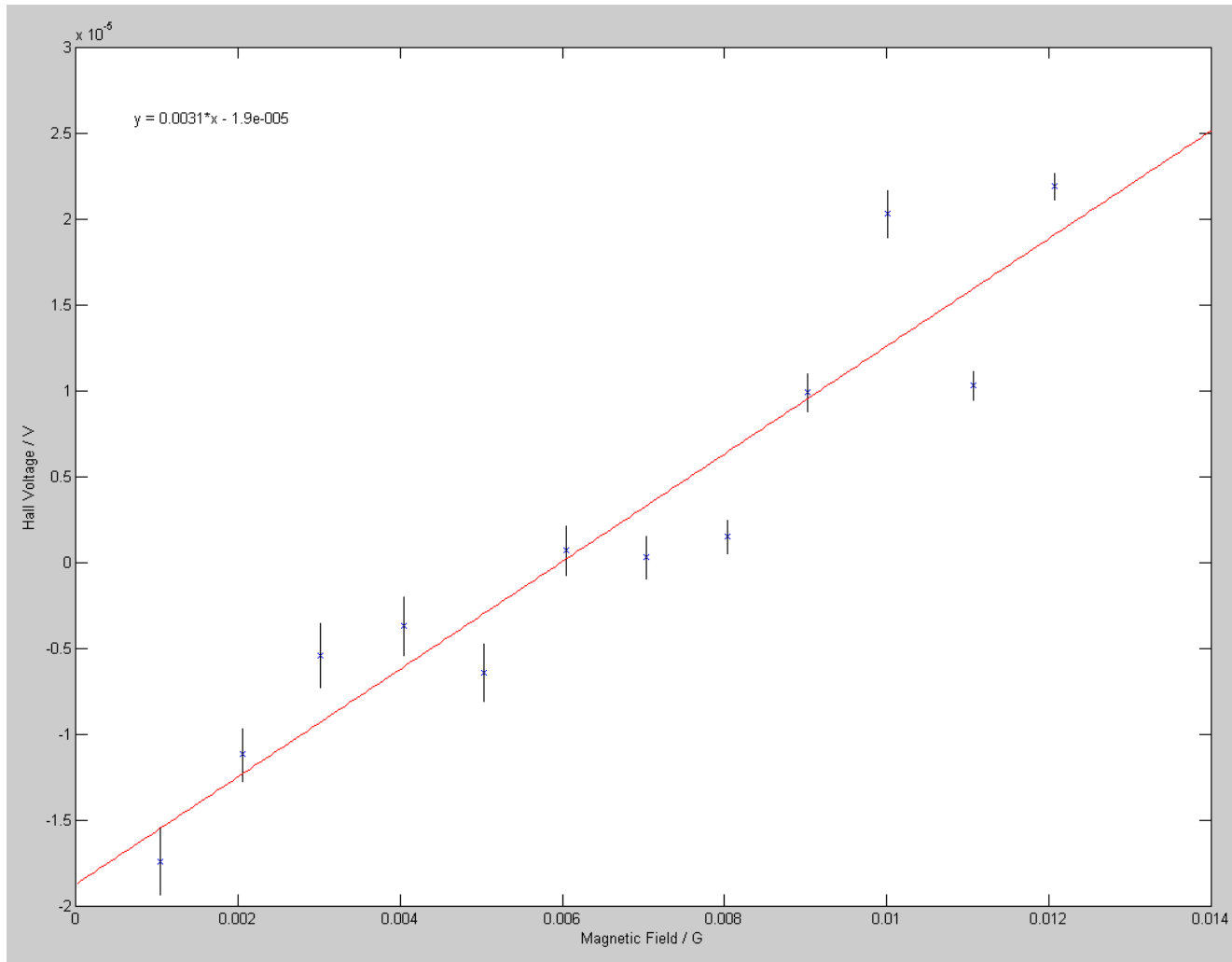
- **Simulated results gradient = $0.0043 \text{ m}^3\text{C}^{-1}$**
- **Measured results gradient = $0.0062 \text{ m}^3\text{C}^{-1}$**
- **This experiment repeated using delta mode to cancel noise**

$$I(t_1) = +I \quad V(t_1) = V_H + V_{\text{noise}}$$

$$I(t_2) = -I \quad V(t_2) = -V_H + V_{\text{noise}}$$

$$V_H = (V(t_1) - V(t_2))/2$$

B vs. V_H in Delta Mode



- **Simulated results** gradient = $0.0043 \text{ m}^3\text{C}^{-1}$
- **Measured results** gradient = $0.0031 \text{ m}^3\text{C}^{-1}$
- Assuming initial value taken for doping ratio was wrong, we can approximate the values of μ_e and μ_h and get new doping ratio using this measured value of gradient
Doping Ratio = 7.3×10^7 (initially assumed to be 1×10^8)

- Any inaccuracy in the measurement may be caused by
 - A contact being non-ohmic
 - The delay between delta measurements being larger than the time constant for the noise

Further improvements

- **Van der Pauw technique can be used**
- **A more accurate helm holtz coil with a constant current**
- **Conduct experiment at lower temperatures to reduce thermal noise**
- **Make sure circuit is of uniform temperature to reduce thermal gradients**



Questions?